



2153 #3
BT
11/14/02

PATENT
Attorney Docket No.: AVALUC-01800

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:

Louis Bouchard

Serial No.: 09/842,747

Filed: April 25, 2001

For: **MAILBOX ACCESS MECHANISM
OVER LOW-BANDWIDTH, HIGH-
LATENCY WIRELESS
NETWORKS**

Group Art Unit: 2153

Examiner:

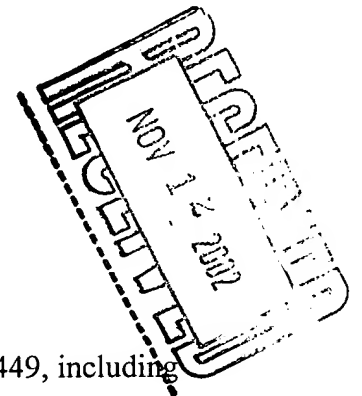
TRANSMITTAL LETTER

162 North Wolfe Road
Sunnyvale, CA 94086
(408) 530-9700

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Assistant Commissioner of Patents
Washington, D.C. 20231

Sir:

Enclosed please find an Information Disclosure Statement, Form PTO-1449, including reference contained thereon, for filing in the U.S. Patent and Trademark Office.

The Commissioner is hereby authorized to charge any additional fee or credit any overpayment to Lucent Technologies Deposit Account No. 12-2325. **An originally executed duplicate of this transmittal is enclosed for this purpose.**

Respectfully submitted,

HAVERSTOCK & OWENS LLP

Dated: October 30, 2002

By: Jonathan O. Owens

Jonathan O. Owens

Reg. No.: 37,902

Attorneys for Applicant

CERTIFICATE OF MAILING (37 CFR § 1.8(a)),

I hereby certify that this paper (along with any referred to as being attached or enclosed) is being deposited with the U.S. Postal Service on the date shown below with sufficient postage as first class mail in an envelope addressed to the: Assistant Commissioner for Patents, Washington D.C. 20231

- 1 -

HAVERSTOCK & OWENS LLP.

Date: 10.30.02 By: J. Owens



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) Group Art Unit: 2153

) Examiner:

) **INFORMATION DISCLOSURE**
) **STATEMENT**

) 162 N. Wolfe Road
) Sunnyvale, CA 94086
) (408) 530-9700

Assistant Commissioner for Patents
Washington, D.C. 20231

Sir:

The citations listed below, copies attached, may be material to the examination of the above-identified application, and are therefore submitted in compliance with the duty of disclosure defined in 37 C.F.R. §§ 1.56 and 1.97. The Examiner is requested to make these citations of official record in this application.

Applicants have become aware of the following printed publications which may be material to the examination of this application:

- U.S. Patent No. 5,949,776; and
- U.S. Patent No. 6,289,212 B1.

This Information Disclosure Statement under 37 C.F.R. §§ 1.56 and 1.97 is not to be construed as a representation that a search has been made, that additional information material to the examination of this application does not exist, or that anyone or more of these citations constitutes prior art.

Respectfully submitted,
HAVERSTOCK & OWENS LLP

Dated: October 30, 2002

By: Jonathan O. Owens
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Attorneys for Applicant

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HAVERSTOCK & OWENS LLP.

Date: 10-30-02 By: [Signature]

FORM PTO-1449
(Modified)U.S. Department of Commerce
Patent and Trademark Office

Attorney Docket No.: AVALUC-01800

Serial No.: 09/842,747

INFORMATION DISCLOSURE STATEMENT BY APPLICANT

(Use Several Sheets If Necessary)

Applicant: Louis Bouchard

Filing Date: April 25, 2001

Group Art Unit: 2153

(37 CFR § 1.98(b))

U.S. PATENT DOCUMENTS

Examiner Initials		Serial / Patent Number	Issue Date	Applicant / Patentee	Class	Subclass	Filing Date
	AA	5,949,776	09/07/99	Mahany et al.	370	338	08/12/97
	AB	6,289,212 B1	09/11/01	Stein et al.	455	412	10/13/98
	AC						
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FOREIGN PATENTS OR PUBLISHED FOREIGN PATENT APPLICATIONS

		Document Number	Publication Date	Country / Patent Office	Class	Subclass	Translation	
							Yes	No
	AK							
	AL							
	AM							
	AN							
	AO							

OTHER DOCUMENTS (Including Author, Title, Date, Relevant Pages, Place of Publication)

	AP	
	AQ	
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Examiner:

Date Considered:

EXAMINER: Initial citation considered. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.